


<b>Search Notes</b>  	<b>Application/Control No.</b>  10709975	<b>Applicant(s)/Patent Under Reexamination</b>  BEAN, RON M.
	<b>Examiner</b>  Urszula M Cegielnik	<b>Art Unit</b>  3711

SEARCHED			
Class	Subclass	Date	Examiner
446	207-209,397,193,418	7/18/2008	UMC

SEARCH NOTES		
Search Notes	Date	Examiner

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
	See EAST Text Search History	7/21/2008	UMC